



| FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT | | | | Atty Docket F98ED0762 | | U.S. Application No.: 09/625,178 | |
|--|----|---------------------------------------|----------|-----------------------------------|-------------------------|-------------------------------------|------------------|
| | | | | Applicant Hiroki Nakamura | | | |
| | | | | U.S. Filing Date July 25, 2000 | | Group 2814 | |
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| A.M | AL | Japanese Laid open patent 07-161706 ✓ | 6/23/95 | JAPAN | H01L | 21/316 | Full translation |
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| Examiner ANH D. MAI | | | | | Date Considered 5/03/05 | | |
| EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant. | | | | | | | |

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